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Knepper

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

MIZUHARA et al.

Serial No.: 09/037,674

Filed: March 9, 1998

Atty. File No.: 2933SE-11-CIP-2

For: "SEMICONDUCTOR DEVICES
PASSIVATION FILM"

Assistant Commissioner for Patents
Washington, D.C. 20231

) Group Art Unit: 2814

) Examiner:

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING
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BY: *Aimee Thuek*
SHERIDAN ROSS P.C.

Dear Sir:

Pursuant to the duty of disclosure under 37 CFR § 1.56 and 37 CFR §§ 1.97-1.98, Applicants
hereby provide a copy of each of the documents identified on the enclosed PTO Form 1449, although
Applicants do not admit that any of such documents, alone or in any combination, is considered to be
material to patentability as defined in 37 CFR § 1.56(b). Moreover, the inclusion of these documents
is not to be construed as an admission by Applicants that each such document is prior art as to the
above-identified patent application.

Respectfully submitted,

SHERIDAN ROSS P.C.

TC 2000
11-23-99
U.S. Patent and Trademark Office

Date: November 23, 1999

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